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Dated: April 17, 2008  
Electronic Signature for Yung-Hoon Ha: /Yung-Hoon Ha/

Docket No.: 42697-147 US2  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Roy G. GORDON et al. Confirmation No.: 5616  
Application No.: 10/520,456 Art Unit: 2813  
Filed: January 6, 2005 Examiner: S. McCall Shepard  
Title: VAPOR DEPOSITION OF TUNGSTEN NITRIDE

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated March 18, 2008, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.